



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the Application of

BILL H QUON, et al.

Group Art Unit: 2821

Application No.: 10/743,264

Examiner:

Filed: December 23, 2003

Confirmation No.:

For: INTER-STAGE PLASMA SOURCE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

This application is one of a series of related applications, identified in the attached Appendix, which are directed to related technical subject matter. The identification of those U.S. Patent Applications is not to be construed as a waiver of secrecy as to those applications now or upon issuance of the present application as a patent. The Examiner is respectfully requested to consider the cited applications and the art cited therein during examination.

This Information Disclosure Statement is being filed before the mailing date of the first Office Action on the merits in the present application. No certification or fee is required.

Respectfully Submitted,


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APPENDIX

Examiner's Initials	First Inventor	Application No.	Filing Date	Enclosed
	QUON	10/378,691	3/5/03	<input checked="" type="checkbox"/> Specification <input type="checkbox"/> Drawings
	QUON	10/739,948	12/19/03	<input checked="" type="checkbox"/> Specification <input type="checkbox"/> Drawings

The Examiner's initials indicates he/she has considered the cited application relative to the subject application.

DO NOT PRINT the above information on the patent which results from the subject application.